



EFW

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q79889

Yoshitaka NAKAMURA, et al.

Appln. No.: 10/777,704

Group Art Unit: 2826

Confirmation No.: 5693

Examiner: Thomas L. Dickey

Filed: February 13, 2004

For: SEMICONDUCTOR DEVICE AND FABRICATION METHOD THEREFOR

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated April 22, 2006, please amend the above-identified application as follows on the accompanying pages.

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